

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q80755

Kesahiro KOIKE

Appln. No.: 10/809,523

Group Art Unit: 1792

Confirmation No.: 7526

Examiner: Lan Vinh

Filed: March 26, 2004

For: METHOD OF PRODUCING A GLASS SUBSTRATE FOR A MASK BLANK AND  
METHOD OF PRODUCING A MASK BLANK

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of three month(s), extending the time for responding to the Office Action of June 4, 2008 to December 4, 2008.

The statutory fee of \$1110.00 is being charged to Deposit Account No. 19-4880 via EFS Payment Screen. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

*/Alan J. Kasper/*

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Date: December 3, 2008